PATENT APPLICATION

HE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |) |
|--------------------------------------|---------------------------|
| | : Examiner: R. E. Fuller |
| Hiroshi KUROSAWA |) |
| | : Group Art Unit: 2851 |
| Application No.: 10/676,156 |) |
| | : Confirmation No.: 6709 |
| Filed: October 2, 2003 |) |
| | : Allowed: April 18, 2005 |
| For: EXPOSURE APPARATUS, MAINTENANCE | |
| METHOD THEREFOR, SEMICONDUCTOR | : June 7, 2005 |
| DEVICE MANUFACTURING METHOD, |) |
| AND SEMICONDUCTOR | : |
| MANUFACTURING FACTORY |) |

Mail ISSUE FEE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

LETTER TRANSMITTING REPLACEMENT DRAWING SHEET

Sir:

Transmitted herewith is one (1) formal drawing sheet, Figure 4, to be substituted for the corresponding drawing sheet currently on file in the above-identified application.

In Figure 4, in step 401, "SHOT" has been corrected to read -- EXECUTE --, as requested by Applicant in a Request for Approval of Drawing Change filed October 2, 2003, which was subsequently approved by the Examiner in the Office Action dated October 22, 2004.

Favorable consideration is requested.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicant

Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
SEW/eab

DC_MAIN 205362v1